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# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Sheet 1 of 1

Application No. :

Filing Date :

First Named Inventor: Y. ABE

Group Art Unit :

Examiner Name :

Attorney Docket No. : KAM 20.716

## U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document	Kind Code if known <sup>2</sup>	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear

## FOREIGN DOCUMENTS

Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document Office <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Country	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YY/Y	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear
<i>W</i>		2003-324825	JP	INOAC CORP	11-14-2003	
<i>W</i>		59-204625	JP	DAICEL CHEM IND LTD	11-20-1984	

## Other Prior Art-Non Patent Literature Documents

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, country, where published, source.	Applicant check her if English language translation attached
<i>W</i>		JAPAN SOCIETY FOR THE PROMOTION OF SCIENCE COMMITTEE NO.166. ON TRANSPARENT OXIDE OPTICAL AND ELECTRICAL MATERIALS. Technology OF Transparent Conducting Films. 1999.	
<i>W</i>		JOHN L. VOSSEN. RF Sputtered Transparent Conductors The System In <sub>2</sub> O <sub>3</sub> -SnO <sub>2</sub> . RCA Review, Vol. 32 June 1971 pgs 289-296	

Examiner Signature

Date Considered

4/28/05

Examiner: Initial reference considered, whether or not citation is in conformance with MPEP 609. Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.1<sup>6</sup> if possible. <sup>7</sup>Applicant is to place a check mark here if English language translation is attached.

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